=> IFW: Scan as Doc Code: SRNT <= Doc Date:

## **TC 3700 Inventor Search Program**

See attached inventor searches for applications and/or patents to help resolve questions of overlapping subject matter. These searches are provided as an initial examination aid: examiners should perform updated or expanded PALM or EAST inventors searches as appropriate.

**Serial Number:** 10820853

1.) See <u>attached</u> printout of inventors listed in PALM

2.) See <u>attached</u> EAST Inventor Search Printout shows Inventor search terms

TIG	710	1 20251020		120/150	1420/457 420/601 420/602	
US	US-	20051020	Method for fabricating	438/459	438/457; 438/691; 438/692	Arai, Kazuhisa
20050233548	PGPUB		semiconductor wafer			
A1 US	US-	20051006	Wafaranaanina mathad	438/458	438/17; 438/459	Arai, Kazuhisa
20050221584	PGPUB	20031006	Wafer processing method	430/430	438/17, 438/439	Arai, Kazuilisa
	rarub					
A1 US	US-	20050901	Method for aligning	313/309	313/311	Tsuruoka, Yuji et al.
20050189859	PGPUB	20030901	needle-like structures and	313/307	313/311	1 Suruoka, Tuji et ai.
A1	10.05		alignment unit			
US	US-	20050707	Chemical feeding device	221/242	221/129; 700/237	Mori, Takashi et al.
20050145644	PGPUB					
Al	10.02					
US	US-	20050623	Method and apparatus for	257/200		Mori, Takashi et al.
20050133823	PGPUB		forming a wiring, wiring			,
A1			board, and ink set			
US	US-	20050609	Medicine feeding	312/209		Kobayashi, Koichi et al.
20050122010	PGPUB		apparatus			
Al						
US	US-	20050602	Medicine feeding	141/104		Kobayashi, Koichi et al.
20050115634	PGPUB		apparatus			
Al						
US	US-	20050519	Method of manufacturing	438/459		Arai, Kazuhisa
20050106840	PGPUB		semiconductor wafer			
Al						
US	US-	20050519	Liquid discharge apparatus	347/47		Tsuruoka, Yuji et al.
20050104932	PGPUB		and method for aligning			
Al			needle-like substances	205/54	205/112 205/112	A ' W I ' was at all
US	US-	20050519	Method of producing	205/74	205/112; 205/118	Arai, Kazuhisa et al.
20050103635	PGPUB		micro component			
A1 US	US-	20050421	Flat-object holder and	451/41		Shimobeppu, Yuzo et al.
20050085171	PGPUB	20030421	method of using the same	431/41		Similoceppu, 1 uzo et ui.
Al	10105		method of using the same			
US	US-	20050217	Ground fish meat products	426/643		Kimura, Ikuo et al.
20050037128	PGPUB	20050217	starting with protease-			
A1	1 01 02		containing fish meat			
US	US-	20050210	Optical switching	398/45		Kakizaki, Sunao et al.
20050031346			apparatus, optical			
Al		ļ	transmission system and			
	:		method of setting up for			
			optical signal route			
US	US-	20050113	Tau-opathy model	435/6	435/194; 435/254.2;	Van Lueven, Freddy et al.
20050009019	PGPUB				435/483; 435/69.1; 536/23.2	
Al					100/100	
US	US-	20041202	Method for processing soi	438/459	438/403	Takahashi, Toshiaki et al.
20040241961	PGPUB		substrate			
Al	110	20041111	D CII : " C	406/201	<del> </del>	Mani Talasahi sa si
US	US-	20041111	Frozen fillet or slice of	426/321		Mori, Takashi et al.
20040224061	PGPUB		fish meat, or a frozen processed fillet or slice of			
Al			fish meat, in which			
			degeneration due to			
			TMAO is inhibited or			
			prevented during freeze-			
			storage			
	<u> </u>	l	1 0:0:450	<u> </u>		<u> </u>

US				<u> </u>	1.53.10.6	1 451/44	
Network   Netw	US	US-	20041021	Polishing material and	451/36	451/41	Tsumagari, Akio et al.
US-   2004020818   PGPUB   20041021   Machine for processing electrodes formed on a plate-like workpiece   228/6.2   228/49.1   Arai, Kazuhisa et al.		PGPUB					
20040208718   PGPUB							
AT   US			20041021		409/139	409/166; 409/167	Arai, Kazuhisa et al.
US_ 20040126800   PGPUB	20040208718	PGPUB					·
20040203187   A1			]	plate-like workpiece			
Al	US	US-	20041021	Flip chip bonder	228/6.2	228/49.1	Arai, Kazuhisa et al.
Al	20040206800	PGPUB					
US							
200401201187   PGPUB		US-	20041014	Method for manufacturing	438/106	257/E23.021	Sekiva, Kazuma et al.
A1							
US		10.05		<b>333</b>			
20040192012   PGPUB   Semiconductor chip   A1   US   US   20040185164   PGPUB   Process for producing fermented fish food   A1   US   US   20040184403   PGPUB   PGP		115-	20040930	Method for manufacturing	438/460		Takezoe Kouii et al
A1	_		20040550		130, 100		Takozoo, Itoaji et an
US		I GI OB		semiconductor cmp			
20040185164   PGPUB		LIC	20040022	Decese for meducine	126/612		Doumata Nahuhika et al
Note			20040923		420/043		Dounioto, Nobuliko et al.
US		PGPUB		Termented fish 100d			
Description	Al				250/222	270/216	Oli Maliana
A1			20040923		370/223	3/0/216	Ohira, Masaki et al.
US		PGPUB		multiplex transmission			
20040165618	Al						
A1	US		20040826		370/535		Sugawara, Toshiki et al.
US	20040165618	PGPUB					
US	Al			transmission networks,			
US				and operation method			
269/902   269/				therefor			
20040124413	US	US-	20040701	Wafer support plate	257/48	211/41.1; 211/41.18;	Arai, Kazuhisa et al.
A1		1					
US- 20040097084   PGPUB		. 0. 02					
20040097084   PGPUB	IIS	IIS-	20040520	Method for grinding rear	438/690	257/E21.237	Fukuda, Kazuya et al.
Name			20040320		.50,050		
US 20040092108 A1 US- 20040089958 A1 US- 20040089958 PGPUB A1 US- 20040081460 A1 US- 20030115150 PGPUB A1 US- 20030137652 A1 US- 20030137652 A1 US- 20030137652 A1 US- 2003015529 PGPUB A1 US- 20030619 Forward error correcting code encoding equipment,  WS- 20030115529 PGPUB A1 US- 200306153 PGPUB A1 WS- 20030619 Forward error correcting code encoding equipment,  WS- 20030137652 PGPUB A1 US- 20030619 Forward error correcting code encoding equipment,  WS- 20030115529 PGPUB A1  WS- 20030619 Forward error correcting code encoding equipment,  WS- 20030115529 PGPUB  WS- 20030619 Forward error correcting code encoding equipment,  WS- 2003017652 PGPUB  WS- 20030619 PGPUB		IGIOD					
20040092108		LIC	20040513		438/689		Vajima Koujchi et al
A1 US 20040089958 PGPUB A1 US- 20040081460 A1 US- PGPUB A1 US- 20040081460 A1 US- PGPUB A1 US- BGPUB A1 US- 20030925 Semiconductor wafer assembly and machining apparatus having chuck tables for holding the same US- 20030181150 A1 US- 20030137652 A1 US- 20030137652 A1 US- 2003015529 PGPUB A1 US- BGPUB A1 US- BGPUB A1 Arai, Kazuhisa AFai, Kazuhisa et al. AFai, Kazuhisa			20040313		430/007		Tajima, Hoarem et an
US 20040089958 A1  US- 20040081460 A1  US- 20040081460 A1  US- PGPUB A1  US- 200404089958 A1  US- PGPUB A1  US- 200404081460 A1  US- 20030181150 A1  US- 20030181150 A1  US- 2003018150 A1  US- 20030724  Method and device for easily and rapidly measuring nonlinear refractive index of optical fiber  US- 20030115529 PGPUB  US- 20030619  Forward error correcting code encoding equipment,  Z57/F23.179  Arai, Kazuhisa  Arai, Kazuhisa  Kakizaki, Sunao et al.  Kakizaki, Sunao et al.  Arai, Kazuhisa et al.  S56/73.1  Mori, Takashi  Arai, Kazuhisa et al.		PGPUB		semiconductor water			
20040089958 A1  US 20040081460 A1  US 20040081460 A1  US 20030181150 A1  US 20030137652 A1  US 20030137652 A1  US 2003015529 PGPUB  US 20030619 Forward error correcting code encoding equipment,  Substrate  Substrate  398/33  398/33  Kakizaki, Sunao et al.  Saparatus, optical transmission system and method of setting up for optical signal route  451/285  451/388; 451/41  Arai, Kazuhisa et al.  Mori, Takashi  Saparatus having chuck tables for holding the same  US 20030137652 A1  US 2003015529 PGPUB  Ohira, Masaki et al.		7.10	20040512	Canducton wafen and	257/707	257/E22 170	Arai Kazubisa
A1  US 20040081460 A1  US- PGPUB A1  US- 20030925  Semiconductor wafer assembly and machining apparatus having chuck tables for holding the same  US 20030137652 A1  US- 20030724  Method and device for easily and rapidly measuring nonlinear refractive index of optical fiber  US 20030115529  PGPUB  US- PGPUB  A1  US- 20030724  Method and device for easily and rapidly measuring nonlinear refractive index of optical fiber  TS 20030115529  PGPUB  US- 20030619  Forward error correcting code encoding equipment,  To hira, Masaki et al.		1	20040313		2311191	257/E25.179	Alai, Kazuilisa
US 20040081460 A1  US- PGPUB A1  US- PGPUB A1  US- US- 20030925  US- 20030925  Semiconductor wafer assembly and machining apparatus having chuck tables for holding the same  US 20030137652 A1  US- 20030724  Method and device for easily and rapidly measuring nonlinear refractive index of optical fiber  US- 20030115529  US- PGPUB  A1  US- 20030619  Forward error correcting code encoding equipment,  Takashi  Says/33  Kakizaki, Sunao et al.  Kakizaki, Sunao et al.  Kakizaki, Sunao et al.  Kakizaki, Sunao et al.  Arai, Kazuhisa et al.		PGPUB		substrate			
20040081460 Al apparatus, optical transmission system and method of setting up for optical signal route  US US- PGPUB Al US- PGPUB Al US- 20030925 Semiconductor wafer assembly and machining apparatus having chuck tables for holding the same  US US- PGPUB Al US- PGPUB Al US- 20030724 Method and device for easily and rapidly measuring nonlinear refractive index of optical fiber  US US- PGPUB Al US- 20030619 Forward error correcting code encoding equipment,  Ohira, Masaki et al.					200/22		Training and
transmission system and method of setting up for optical signal route  US 20030181150 A1  US- PGPUB A1  US- 20030925 Semiconductor wafer assembly and machining apparatus having chuck tables for holding the same  US 20030137652 A1  US- 20030724 Method and device for easily and rapidly measuring nonlinear refractive index of optical fiber  US 20030115529 US- 20030619 Forward error correcting code encoding equipment,  Transmission system and method of setting up for optical fiber  451/285 451/388; 451/41  Arai, Kazuhisa et al.		1	20040429	,	398/33		Kakizaki, Sunao et al.
method of setting up for optical signal route  US 20030181150 A1  US- PGPUB A1  US- 20030724  Wethod and device for easily and rapidly measuring nonlinear refractive index of optical fiber  US 20030115529  US- 20030619  Forward error correcting code encoding equipment,  method of setting up for optical signal route  451/285  451/388; 451/41  Arai, Kazuhisa et al.		PGPUB					
US US- PGPUB US- 20030724 Method and device for easily and rapidly measuring nonlinear refractive index of optical fiber  US US- US- PGPUB US- PGPUB US- PGPUB A1 US- PGPUB US- PGPUB US- PGPUB US- PGPUB US- PGPUB US- PGPUB US- Code encoding equipment, PGPUB US- PGPUB US- PGPUB US- Code encoding equipment, PGPUB US- PGPUB US- PGPUB US- Code encoding equipment, PGPUB US- PGPUB US- PGPUB US- Code encoding equipment, PGPUB US- PGPUB US- Code encoding equipment, PGPUB US- PGPUB US- PGPUB US- Code encoding equipment, PGPUB US- PGPUB US- Code encoding equipment, PGPUB US- PGPUB US- Code encoding equipment, PGPUB US-	Al						
US 20030181150 A1  US- PGPUB A1  US- 20030724 PGPUB A1  US- 20030137652 A1  US- 20030619 Forward error correcting code encoding equipment,  Toward error correcting code encoding equipment,  Toward error correcting code encoding equipment,		1					
20030181150 PGPUB assembly and machining apparatus having chuck tables for holding the same  US US- PGPUB A1 Wethod and device for easily and rapidly measuring nonlinear refractive index of optical fiber  US US- PGPUB Toward error correcting code encoding equipment,  Ohira, Masaki et al.	•			optical signal route			
A1 apparatus having chuck tables for holding the same  US US- PGPUB A1 PGPUB  US- US- PGPUB  US- PGPUB  US- US- PGPUB  US- PGPUB  US- PGPUB  US- Code encoding equipment,  A1 PGPUB  A20030115529 PGPUB  A20030115529 PGPUB  A20030115529 PGPUB  A20030115529 PGPUB  A20030115529 PGPUB  A20030724 Method and device for easily and rapidly measuring nonlinear refractive index of optical fiber  A1 PGPUB  A356/73.1  A356/73.1	US	US-	20030925	Semiconductor wafer	451/285	451/388; 451/41	Arai, Kazuhisa et al.
A1 apparatus having chuck tables for holding the same  US US- PGPUB A1 PGPUB  US- US- PGPUB  US- PGPUB  US- US- PGPUB  US- PGPUB  US- PGPUB  US- Code encoding equipment,  A1 PGPUB  A20030115529 PGPUB  A20030115529 PGPUB  A20030115529 PGPUB  A20030115529 PGPUB  A20030115529 PGPUB  A20030724 Method and device for easily and rapidly measuring nonlinear refractive index of optical fiber  A1 PGPUB  A356/73.1  A356/73.1		PGPUB		assembly and machining	[		
US 20030137652 PGPUB PGPUB US- 20030619 Forward error correcting 20030115529 PGPUB tables for holding the same    US 20030724 Method and device for easily and rapidly measuring nonlinear refractive index of optical fiber    US 20030115529 PGPUB Code encoding equipment,    Takashi Mori, Takashi easily and rapidly measuring nonlinear refractive index of optical fiber    Ohira, Masaki et al.	A1						
US 20030137652 PGPUB PGPUB PGPUB Solution and device for easily and rapidly measuring nonlinear refractive index of optical fiber Solution and device for easily and rapidly measuring nonlinear refractive index of optical fiber Ohira, Masaki et al.		1					
20030137652 PGPUB easily and rapidly measuring nonlinear refractive index of optical fiber  US US- 20030619 Forward error correcting code encoding equipment,  Ohira, Masaki et al.	IIS	US-	20030724		356/73.1		Mori, Takashi
A1 measuring nonlinear refractive index of optical fiber  US US- 20030619 Forward error correcting code encoding equipment,  Ohira, Masaki et al.		1					,
refractive index of optical fiber  US US- 20030619 Forward error correcting code encoding equipment,  Ohira, Masaki et al.		. 3. 35				1 .	
US US- 20030619 Forward error correcting code encoding equipment, T14/752 Ohira, Masaki et al.	VI.					•	
US 20030619 Forward error correcting code encoding equipment, 714/752 Ohira, Masaki et al.							
20030115529 PGPUB code encoding equipment,	110	110	20020610	<del></del>	714/752		Ohira Masaki at al
		1	20030619		114/132		Oillia, iviasaki et al.
A1   forward error correcting		PGPUB			1		
	Al	<u> </u>	L	forward error correcting	l		<u> </u>

			code decoding equipment,			
			and transmission apparatus	151/064		
US 20030077993 A1	US- PGPUB	20030424	Flat-object holder and method of using the same	451/364		Shimobeppu, Yuzo et al.
US 20030036343 A1	US- PGPUB	20030220	Machining strain removal apparatus	451/67	451/331	Mizomoto, Yasutaka et al.
US 20030027501 A1	US- PGPUB	20030206	Method of grinding rear side of semiconductor wafer	451/41		Arai, Kazuhisa
US 20030013380 A1	US- PGPUB	20030116	Semiconductor wafer dividing method	451/6		Arai, Kazuhisa et al.
US 20030011756 A1	US- PGPUB	20030116	Projection exposure apparatus with a catadioptric projection optical system	355/71	355/52; 355/53; 355/67; 356/400	Omura, Yasuhiro et al.
US 20020180942 A1	US- PGPUB	20021205	Projection exposure apparatus, projection exposure method and method of manufacturing the projection exposure apparatus	355/67	355/30; 355/53; 355/55; 359/350	Suzuki, Kenji et al.
US 20020159142 A1	US- PGPUB	20021031	Illuminating apparatus	359/350	359/361; 359/614	Hagiwara, Shigeru et al.
US 20020098781 A1	US- PGPUB	20020725	Method, jig, and apparatus for machining rod lenses	451/41	451/285	Koshi, Hiroshi et al.
US 20020091982 A1	US- PGPUB	20020711	Error correction transmission apparatus	714/752		Ohira, Masaki et al.
US 20020081954 A1	US- PGPUB	20020627	Grinding machine	451/65	451/332	Mori, Takashi et al.
US 20020070005 A1	US- PGPUB	20020613	Heat sink, method for manufacturing same, and pressing jig	165/80.3	165/104.33; 29/890.03	Kawabata, Kenya et al.
US 20020054660 A1	US- PGPUB	20020509	PROJECTION EXPOSURE APPARATUS AND METHOD, AND ILLUMINATION OPTICAL SYSTEM THEREOF	378/34	378/84	KOMATSUDA, HIDEKI et al.
US 20020048064 A1	US- PGPUB	20020425	Optical multiple transmission method, optical network and optical transmission apparatus	398/83	398/48; 398/49; 398/93	Yajima, Yusuke et al.
US 20020045348 A1	US- PGPUB	20020418	Semiconductor wafer treating method and device for removing deposit on a semiconductor wafer	438/690	257/E21.237; 438/906	Arai, Kazuhisa

US 20020041368 A1	US- PGPUB	20020411	Apparatus and method for pattern exposure and method for adjusting the apparatus	355/55	250/548; 355/52; 355/53; 355/67; 355/77; 356/399; 356/400	Ota, Kazuya et al.
US 20020025656 A1	US- PGPUB	20020228	Semiconductor chip pick- up method	438/463	257/E21.599	Arai, Kazuhisa et al.
US 20020023340 A1	US- PGPUB	20020228	Method of separating a plate-like workpiece adsorption-held on an elastic adsorption pad	29/825	29/426.1	Arai, Kazuhisa et al.
US 20020004359 A1	US- PGPUB	20020110	Semiconductor wafer grinding Method	451/41	451/54	Arai, Kazuhisa
US 20010053225 A1	US- PGPUB	20011220	Method for encoding/decoding error correcting code, transmitting apparatus and network	380/239		Ohira, Masaki et al.
US 20010049256 A1	US- PGPUB	20011206	Semiconductor wafer assembly and machining apparatus having chuck tables for holding the same	451/289		Arai, Kazuhisa et al.
US 20010046074 A1	US- PGPUB	20011129	Protection switching apparatus for 1 + 1 optical transmission lines	398/5	398/141	Kakizaki, Sunao et al.
US 20010040197 A1	US- PGPUB	20011115	Cutting-and-transferring system and pellet transferring apparatus	241/101.4	241/301	Sekiya, Kazuma et al.
US 20010030740 A1	US- PGPUB	20011018	Optical exposure apparatus and photo-cleaning method	355/53	250/548; 355/67; 355/68; 355/71; 355/77; 356/399; 356/400; 356/401	Mori, Takashi et al.
US 20010029938 A1	US- PGPUB	20011018	Semiconductor wafer cutting machine	125/13.01		Arai, Kazuhisa et al.
US 20010001002 A1	US- PGPUB	20010510	Multiplex transmission apparatuses, multiplex transmission networks, and operation method therefor	370/474	370/522; 370/535	Sugawara, Toshiki et al.
US 6975811 B1	USPAT	20051213	Optical one-to-one protection switching apparatus	398/2	398/5	Kakizaki; Sunao et al.
US 6943045 B2	USPAT	20050913	Semiconductor wafer protective device and semiconductor wafer treatment method	438/17		Kitamura; Masahiko et al.
US 6927416 B2	USPAT	20050809	Wafer support plate	257/48	257/627	Arai; Kazuhisa et al.
US 6909496 B2	USPAT	20050621	Method and device for easily and rapidly measuring nonlinear refractive index of optical fiber	356/73.1		Mori; Takashi
US 6884455	USPAT	20050426	Process for producing	426/643	426/56	Doumoto; Nobuhiko et al.

B2			fermented fish food	<u> </u>		
US 6871314	USPAT	20050322	Forward error correcting	714/776	714/782; 714/784	Ohira; Masaki et al.
B2	001111	20030322	code encoding equipment,	' ' ' ' ' ' '	71 02, 71 70	oma, masaki et ai:
D2			forward error correcting			
			code decoding equipment,			
			and transmission apparatus			
110 (020400	LICDAT	20050104		385/16	285/17: 285/24: 208/140:	Kalsigalsis Suggest al
US 6839480	USPAT	20050104	Optical switching	383/16	385/17; 385/24; 398/140;	Kakizaki; Sunao et al.
B2			apparatus, optical		398/145	İ
			transmission system and			
			method of setting up for			
			optical signal route			
US 6837776	USPAT	20050104	Flat-object holder and	451/41	451/287; 451/289; 451/54	Shimobeppu; Yuzo et al.
B2			method of using the same			
US 6780091	USPAT	20040824	Machining strain removal	451/67	451/285; 451/65	Mizomoto; Yasutaka et al.
B2			apparatus			
US 6778725	USPAT	20040817	Optical switching	385/16	385/17; 385/24	Kakizaki; Sunao et al.
Bl			apparatus, optical		,	ĺ
2.			transmission system and			
			method of setting up for			
			optical signal route			
US 6759274	USPAT	20040706	Semiconductor chip pick-	438/114	257/E21.599; 414/941;	Arai; Kazuhisa et al.
B2	USIAI	20040700	up method	450/114	438/118	Alai, Razumsa et al.
US 6758262	USPAT	20040706	Heat sink, method for	165/80.3	165/185; 257/722;	Kawabata; Kenya et al.
	USPAT	20040706	,	103/80.3		Rawadala, Keliya et al.
B2			manufacturing same, and		29/890.03; 361/697;	
			pressing jig	71 4 / 77 C	361/704	01: 1:
US 6735735	USPAT	20040511	Forward error correcting	714/776	714/774; 714/775	Ohira; Masaki et al.
Bl			code encoding equipment,			
			forward error correcting			
			code decoding equipment,			
			and transmission apparatus			
US 6727980	USPAT	20040427	Apparatus and method for	355/55	355/35; 355/53; 355/67;	Ota; Kazuya et al.
B2			pattern exposure and		355/71; 355/77; 356/399;	
			method for adjusting the		356/400; 359/731; 359/859;	
			apparatus		430/311; 430/312; 430/5	
US 6721268	USPAT	20040413	Method and apparatus for	370/223		Ohira; Masaki et al.
B1	001111	200.000	multiplex transmission			
US 6702652	USPAT	20040309	Method of grinding rear	451/41	156/345.12; 438/692;	Arai; Kazuhisa
B2	051711	20040307	side of semiconductor	131,11	451/63	Thui, Tuzumu
DZ			wafer		451705	
US 6697386	USPAT	20040224	Multiplex transmission	370/535	370/498	Sugawara; Toshiki et al.
	USPAI	20040224		370/333	370/498	Sugawara, Toshiki et al.
B2			apparatuses, multiplex			
			transmission networks,			
			and operation method			
			therefor			
US 6685542	USPAT	20040203	Grinding machine	451/65	451/287; 451/290; 451/332;	Mori; Takashi et al.
B2					451/66	
US 6676491	USPAT	20040113	Semiconductor wafer	451/57	125/13.01; 438/460	Arai; Kazuhisa et al.
B2			dividing method			
US 6670076	USPAT	20031230	Spinel-type lithium-	429/231.95	252/182.1; 252/519.15;	Iwata; Eiichi et al.
B1			manganese oxide		423/599; 429/224;	
			containing heteroelements		429/231.1	
			preparation process and			1
			use thereof			
US 6661499	USPAT	20031209	Projection exposure	355/71	355/67	Omura; Yasuhiro et al.
B2	551711	20031207	apparatus with a			
		1	apparated with a	· · · · · ·	I	

			catadioptric projection			
110.6610001	TIOD AT	20021104	optical system	255/52	250/402 2: 255/67: 255/69	N . T
US 6642994 B2	USPAT	20031104	Optical exposure apparatus and photo-cleaning method	355/53	250/492.2; 355/67; 355/68; 355/69; 355/71; 355/77; 430/30	Mori; Takashi et al.
US 6634933 B2	USPAT	20031021	Method, jig, and apparatus for machining rod lenses	451/42	451/240	Koshi; Hiroshi et al.
US 6614754 B1	USPAT	20030902	Bi-directional line switched ring network system	370/222	370/223	Usuba; Keiji et al.
US 6594890 B2	USPAT	20030722	Method of separating a plate-like workpiece held by adhesion on an elastic adsorption pad	29/830	29/426.1; 29/825; 438/464	Arai; Kazuhisa et al.
US 6528864 B1	USPAT	20030304	Semiconductor wafer having regular or irregular chip pattern and dicing method for the same	257/620	257/622; 257/E21.238	Arai; Kazuhisa
US 6527627 B2	USPAT	20030304	Semiconductor wafer grinding method	451/41	451/57	Arai; Kazuhisa
US 6526118 B2	USPAT	20030225	Projection exposure apparatus and method, and illumination optical system thereof	378/34		Komatsuda; Hideki et al.
US 6500047 B2	USPAT	20021231	Semiconductor wafer cutting machine	451/14	125/13.01; 451/11	Arai; Kazuhisa et al.
US 6494197 B1	USPAT	20021217	Dicing machine for cutting CSP plate into pellets	125/12	125/23.01; 125/35; 451/339	Yoshimura; Eiichi et al.
US 6475672 B1	USPAT	20021105	Lithium manganese oxide, and process for its production and secondary cell employing it	429/224	423/599; 429/231.95	Iwata; Eiichi et al.
US 6466303 B1	USPAT	20021015	Projection exposure apparatus with a catadioptric projection optical system	355/67	355/53; 355/71; 355/77	Omura; Yasuhiro et al.
US 6421604 B1	USPAT	20020716	Map display apparatus for motor vehicle	701/208	340/995.14; 701/200; 701/28	Koyanagi; Takuo et al.
US 6411631 B1	USPAT	20020625	Multiplex type transmitting apparatus	370/465	370/522; 370/538	Sugawara; Toshiki et al.
US 6386191 B1	USPAT	20020514	CSP plate holder	125/35	269/21; 451/388	Yoshimura; Eiichi et al.
US 6382609 B1	USPAT	20020507	Chuck table	269/21		Namioka; Shinichi et al.
US 6358132 B1	USPAT	20020319	Apparatus for grinding spherical objects	451/296	451/300; 451/302	Arai; Kazuhisa et al.
US 6341740 B1	USPAT	20020129	Cutting-and-transferring system and pellet transferring apparatus	241/101.2	241/301; 451/182; 83/704	Sekiya; Kazuma et al.
US 6286499 B1	USPAT	20010911	Method of cutting and separating a bent board into individual small divisions	125/12	125/901; 257/E21.238; 257/E21.599; 83/35; 83/36; 83/39; 83/880; 83/886	Yoshii; Masahiro et al.
US 6268904 B1	USPAT	20010731	Optical exposure apparatus and photo-cleaning	355/53	250/492.2; 355/67; 355/68; 355/69; 355/71; 430/30	Mori; Takashi et al.

	<del></del>		method	<u> </u>		<u> </u>
US 6250990	USPAT	20010626	CSP plate cutting	451/5	125/13.01; 125/23.01;	Yoshii; Masahiro et al.
Bl	ļ <sup>-</sup>		apparatus		451/10; 451/11	
US 6219336 B1	USPAT	20010417	Terminal multiplexer and method of constructing the terminal multiplexer	370/223	370/228; 370/535	Takahashi; Masatoshi et al.
US 6175800 B1	USPAT	20010116	Route searching device	701/202	340/995.19; 701/201; 701/208; 701/209; 701/25; 701/35	Mori; Takashi et al.
US 6169754 B1	USPAT	20010102	Multiplex transmission apparatuses, multiplex transmission networks, and operation method therefor	370/535	370/498	Sugawara; Toshiki et al.
US 6168888 B1	USPAT	20010102	Spinel-type lithium- manganese oxide containing heteroelements, preparation process and use thereof	429/231.95	252/182.1; 252/519.15; 423/599; 429/224; 429/231.1	Iwata; Eiichi et al.
US 6108126 A	USPAT	20000822	Illuminating apparatus	359/361	313/112; 313/635; 355/71; 359/358; 359/359; 362/255; 362/293	Hagiwara; Shigeru et al.
US 6094440 A	USPAT	20000725	Multiplex type transmitting apparatus	370/465	370/522; 370/538; 370/907	Sugawara; Toshiki et al.
US 6049525 A	USPAT	20000411	Terminal multiplexer and method of constructing the terminal multiplexer	370/223	370/228; 370/535	Takahashi; Masatoshi et al.
US 6036939 A	USPAT	20000314	Heat-resistant low-silica zeolite, and process for production and application thereof	423/710	423/711; 423/DIG.21; 502/79; 95/130; 95/96	Funakoshi; Hajime et al.
US 6012014 A	USPAT	20000104	Map display apparatus for motor vehicle	701/208	701/207; 701/211; 701/212; 701/28	Koyanagi; Takuo et al.
US 5997079 A	USPAT	19991207	Head lining of automobile	296/214		Kuwabara; Akira et al.
US 5995633 A	USPAT	19991130	System and method for multiplexing control signals over data signal conductors	381/123	381/74	Cappels; Richard D. et al.
US 5978733 A	USPAT	19991102	Route search apparatus	701/209	340/988; 340/990; 701/201; 701/206; 701/207; 701/208	Deshimaru; Masatsugu et al.
US 5906429 A	USPAT	19990525	Optical illumination device	362/293	250/492.2; 362/264; 362/294; 362/345; 362/96; 95/137; 95/141; 96/142	Mori; Takashi et al.
US 5891806 A	USPAT	19990406	Proximity-type microlithography apparatus and method	438/707	216/66; 355/66; 355/67; 438/942	Shibuya; Masato et al.
US 5862498 A	USPAT	19990119	Map display apparatus for motor vehicle	701/28	340/995.14; 701/211; 701/25	Koyanagi; Takuo et al.
US 5791767 A	USPAT	19980811	Semiconductor exposure device	362/268	315/291; 362/263; 362/295	Inoue; Osamu et al.
US 5760963 A	USPAT	19980602	Fly-eye lens, illumination optical apparatus, and exposure apparatus	359/622	359/623; 359/626	Mori; Takashi
US 5745535	USPAT	19980428	Precision symbol	375/355		Mori; Takashi

	1 -	· · · · ·			1	
Α			discrimination timing			
			detection (clock recovery)			
			system for multi-carrier			
<del></del>		10000000	modulation signal		200/004 200/004 200/004	
US 5717722	USPAT	19980210	Precision symbol	375/326	329/304; 329/306; 375/261	Mori; Takashi
Α			demodulation system for			
	İ		multi-carrier modulation			
			signal			
US 5713660	USPAT	19980203	Illumination optical	362/268	353/38; 355/53; 355/67;	Mori; Takashi et al.
Α			apparatus		362/331	
US 5675895	USPAT	19971014	Portable circular saw	30/124	30/390; 451/456	Mori; Takashi et al.
Α			having a dust collecting			
			function			
US 5669708	USPAT	19970923	Optical element,	362/341	359/619; 362/347; 378/34;	Mashima; Kiyoto et al.
Α	ļ		production method of		378/84	·
			optical element, optical			
			system, and optical			
			apparatus			
US 5640284	USPAT	19970617	Optical reflector,	359/869	359/365; 359/389; 359/482;	Tanitsu; Osamu et al.
Α	1		illumination optical		359/867; 359/868; 362/268;	ĺ
			system, light source		362/291; 362/347	
	1		system and illumination			į į
			optical apparatus			
US 5636003	USPAT	19970603	Illumination optical	355/67	355/53; 359/618	Tanitsu; Osamu et al.
A			apparatus and scanning		<u> </u>	<b>'</b>
			exposure apparatus			
US 5631402	USPAT	19970520	Process for preparing	562/453	562/433	Miyazawa; Shuhei et al.
A			aminobenzoic acid			
**			derivatives			
US 5615047	USPAT	19970325	Illumination apparatus and	359/618	359/798; 362/268	Komatsuda; Hideki et al.
A			exposure apparatus using			
			it			
US 5599972	USPAT	19970204	Aminobenzoic acid	562/433	546/124; 560/46	Miyazawa; Shuhei et al.
A			derivatives		,	
US 5594526	USPAT	19970114	Optical integrator and	355/67	353/32; 359/619; 359/620;	Mori; Takashi et al.
A			projection exposure		362/268	
			apparatus using the same			
US 5581605	USPAT	19961203	Optical element,	378/84	359/619; 378/34	Murakami; Katsuhiko et
A	001111	1,550,200	production method of	370707	5537613,57673.	al.
	i		optical element, optical			
			system, and optical			
			apparatus			
US 5578603	USPAT	19961126	Aminobenzoic acid	514/304	546/125	Miyazawa; Shuhei et al.
A	OSIAI	17701120	derivatives	314,304	340/123	winyazawa, Silaner et al.
US 5485075	USPAT	19960116	Reactive power	323/207	323/205	Mori; Takashi et al.
A	001711	17700110	compensating apparatus	323/207	323/203	l word, runusm et un
71			and method for reducing in			
			switching loss in steady			
			state operation thereof		•	
US 5471278	USPAT	19951128	Cadmium/rare gas	355/67	313/571; 313/606; 313/638;	Yasuda; Yukio et al.
OS 3471278	OSIAI	19931120	discharge lamp of the short	333,07	355/71	1 asuda, 1 ukio et al.
Л	1		arc type, as well as		33371	
			projection exposure device			
US 5424163	USPAT	19950613	using the same Picture recording method	430/124	420/117: 420/126: 420/00	Tokunaga; Hiroshi et al.
03 3424103	USPAI	17730013	ricture recording memod	430/124	430/117; 430/126; 430/99	i okunaga, mirosin et al.

ر -

<u>A</u>	<u>-</u> -	<u> </u>	using a dispersant having	1		1
A			coloring agent particles			
US 5389643 A	USPAT	19950214	Aminobenzoic acid derivatives useful for treating gastro-intestinal conditions	514/304	546/124; 546/125; 546/127	Miyazawa; Shuhei et al.
US 5372112 A	USPAT	19941213	Device for controlling a multi-cylinder engine	123/406.13	123/479	Ohtaka; Yukio et al.
US 5331639 A	USPAT	19940719	Method and apparatus for frame phase conversion of signal having frame structure	370/506	370/516; 375/371	Takatori; Masahiro et al.
US 5319139 A	USPAT	19940607	Naphthalene derivatives	564/173	558/417; 560/139; 562/444; 562/450; 564/163; 564/169	Yoshimura; Hiroyuki et al.
US 5307863 A	USPAT	19940503	Method for continuous casting of slab	164/466	164/468	Kubota; Jun et al.
US 5300952 A	USPAT	19940405	Thermal image forming equipment forms image directly on image carrier or paper sheet	347/217	346/135.1; 347/212	Wada; Takeo et al.
US 5296892 A	USPAT	19940322	Illuminating apparatus and projection exposure apparatus provided with such an illuminating apparatus	355/67	355/53	Mori; Takashi
US 5283782 A	USPAT	19940201	System switching method and apparatus without loss of signal in cell switching system of asynchronous transfer mode	370/219	370/398	Takase; Akihiko et al.
US 5262565 A	USPAT	19931116	Naphthalene derivatives	562/466	560/53; 560/56; 562/461	Yoshimura; Hiroyuki et al.
US 5245384 A	USPAT	19930914	Illuminating optical apparatus and exposure apparatus having the same	355/67	355/53; 362/268	Mori; Takashi
US 5237091 A	USPAT	19930817	Naphthalene derivatives	560/53	562/462; 568/328; 568/633	Yoshimura; Hiroyuki et al.
US 5236632 A	USPAT	19930817	Zinc oxide sintered body, and preparation process and use thereof	252/519.5	252/519.52; 252/519.54; 501/1	Ogawa; Nobuhiro et al.
US 5225916 A	USPAT	19930706	Image reading method for an image recording system	358/471	358/409; 358/474; 358/494	Kikugawa; Makoto et al.
US 5219794 A	USPAT	19930615	Semiconductor integrated circuit device and method of fabricating same	228/121	228/180.22; 257/E21.499; 257/E21.505; 257/E23.193; 29/840; 438/126	Satoh; Toshihiko et al.
US 5219600 A	USPAT	19930615	Molded product for colored food	426/106	426/415; 524/125; 524/151; 524/153	Kosegaki; Kimiho et al.
US 5208612 A	USPAT	19930504	Image recording apparatus constituting of selectable units	347/152	355/27; 399/361	Obu; Makoto et al.
US 5207505 A	USPAT	19930504	Illumination light source device	362/373	362/294; 362/345; 392/426	Naraki; Tsuyoshi et al.
US 5206858 A	USPAT	19930427	Transmission method and circuit of virtual container	370/465	370/474	Nakano; Yukio et al.

	T T		using asynchronous			
US 5107277	USPAT	19920421	transfer mode Current sensitized transfer	347/199	346/139C	Mori; Takashi
A	OSIAI	17920421	type printer with a heated common electrode			iviori, rukusiir
US 5079566 A	USPAT	19920107	Printing apparatus with a printhead having stratified recording electrodes, return electrode and preheating electrode for use with resistive thermal transfer ribbon	347/187	346/139C	Mori; Takashi
US 5079564 A	USPAT	19920107	Recording apparatus using a time varying distribution of heat element driving pulses	347/183	347/199	Sasaki; Eiichi et al.
US 5007204 A	USPAT	19910416	Apparatus for shaping ingots into right circular cylindrical form	451/11	451/243; 451/49; 451/5	Ibe; Hiroyuki et al.
US 4983994 A	USPAT	19910108	Thermal transfer type printing device	347/196	347/16; 347/193	Mori; Takashi et al.
US 4951422 A	USPAT	19900828	External cylindrical grinding unit	451/5	451/398; 451/49	Ibe; Hiroyuki et al.
US 4909913 A	USPAT	19900320	Method for recovering a metal	205/560	204/296; 205/565; 521/25; 521/27	Fukuda; Kenichi et al.
US 4898226 A	USPAT	19900206	Immersion nozzle for continuous casting of steel	164/415	164/437; 222/603	Teshima; Toshio et al.
US 4890120 A	USPAT	19891226	Thermal transfer type printing device capable of selecting ink sheets	347/175	347/193; 347/217; 400/206; 400/237; 400/240.3; 400/249; 400/703	Sasaki; Eiichi et al.
US 4877498 A	USPAT	19891031	Method for producing a metal salt by electrolysis	205/477	204/296; 521/27	Fukuda; Kenichi et al.
US 4852633 A	USPAT	19890801	Immersion nozzle for continuous casting of steel	164/437	164/337; 222/591	Teshima; Toshio et al.
US 4816479 A	USPAT	19890328	Xanthone derivatives and process for producing the same	514/455	514/869; 549/392	Koga; Hiroshi et al.
US 4806987 A	USPAT	19890221	Projection-exposing apparatus	355/53		Mori; Takashi et al.
US 4707234 A	USPAT	19871117	Method for separating an acid and an alkali from an aqueous solution of a salt	204/522	204/296	Mori; Takashi et al.
US 4691018 A	USPAT	19870901	Pyridine derivatives and their use as anti-allergic agents	546/309	546/323	Mori; Takashi et al.
US 4666256 A	USPAT	19870519	Microscope objective lens	359/658		Shimizu; Yoshiyuki et al.
US 4661607 A	USPAT	19870428	Furoxanthone derivatives useful as diuretics	549/383	549/392	Koga; Hiroshi et al.
US 4627316 A	USPAT	19861209	Automatic screwdriver	81/430	227/117; 81/435; 81/57.37	Mori; Takashi et al.
US 4576344 A	USPAT	19860318	Polyester film roll	242/547	242/160.4; 242/541.1	Sasaki; Ichitaro et al.
US 4495841 A	USPAT	19850129	Automatic screwdriver	81/430	227/117; 81/435; 81/57.37	Mori; Takashi et al.

US 4436551 A	USPAT	19840313	Process for making steel from direct-reduced iron	75/10.15	75/10.34; 75/10.6; 75/475; 75/503	Mori; Takashi
US 4418765 A	USPAT	19831206	Power-driven screwdriver with a torque control	173/182	81/470	Mori; Takashi et al.
US 4366161 A	USPAT	19821228	Nicotinamide derivative, process for preparing the same and pharmaceutical composition containing the same	514/332	514/824; 546/262	Mori; Takashi et al.
US 4361572 A	USPAT	19821130	Tetrahydronicotinamide derivative, pharmaceutical compositions and use	514/332	514/355; 514/886; 546/261; 546/262; 546/316	Takaku; Sakae et al.
US 4324768 A	USPAT	19820413	Process for preparation of lead compounds	423/92	106/432; 423/305; 423/311; 423/326; 423/433; 423/436; 423/512.1; 423/559; 423/595; 423/620; 556/105; 556/106; 556/35; 556/83	Sugahara; Yujiro et al.
US 4221814 A	USPAT	19800909	Terephthalic acid monoamide derivatives, process for preparing the same, and an anti-allergic agent prepared from the same	514/533	514/568; 544/92; 560/48; 562/457	Takaku; Sakae et al.
US 4200640 A	USPAT	19800429	Nitric ester of N-(2- hydroxyethyl)nicotinamide and pharmaceutical use	514/355	546/316; 546/323	Nagano; Hiroyuki et al.
US 4110169 A	USPAT	19780829	Method for manufacturing high-strength formed coke in slight mutual agglomeration using horizontal type coke oven battery	201/6	201/23; 201/24; 201/42; 201/8	Suzuki; Gyoichi et al.
US 4092431 A	USPAT	19780530	Pharmaceutical composition and method of the use thereof	514/616	514/925; 514/927	Mori; Takashi et al.
US 4058523 A	USPAT	19771115	Bis(benzamido)-benzene derivatives	544/165	544/393; 544/395; 546/234; 560/138; 564/153; 564/157; 564/163; 564/166	Mori; Takashi et al.
US 4038416 A	USPAT	19770726	Pharmaceutical composition and method of the use thereof	514/616	514/925; 514/927; 564/157	Mori; Takashi et al.
US 4029266 A	USPAT	19770614	Automatic thread winding apparatus	242/473.6		Mori; Takashi et al.
US 3953496 A	USPAT	19760427	Bis(benzamido)-benzoic acid derivatives	560/45	562/453; 562/458; 562/477; 564/153	Mori; Takashi et al.
US 3594987 A	USPAT	19710727	METHOD OF RECOVERING AMMONIA GAS FROM AQUEOUS SOLUTION CONTAINING AMMONIA AND CARBON DIOXIDE	95/263	558/419; 564/67; 95/265	Oda; Kenzo et al.
US 3465040 A	USPAT	19690902	2,3-DECAMETHYLENE- CYCLOPENTANONE [TEXT AVAILABLE IN	568/354	512/15; 549/345; 549/462; 560/127; 568/375	NOZAKI HITOSI et al.

	USOCR DATABASE]		 	

,